



PATENT

Atty. Dkt. No. APPM/002622.D1/CMP/ECP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Dordi, et al.

Serial No.: 10/630,185

Confirmation No.: 9224

Filed: July 29, 2003

For: Electro-Chemical
Deposition Cell for Face-Up
Processing of Single
Semiconductor Substrates

MAIL STOP RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Examiner: Edna Wong

CERTIFICATE OF MAILING
37 CFR 1.8

PRELIMINARY AMENDMENT

Prior to a continuing examination, please amend the above identified application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 6 of this paper.